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DIALOG(R)File 345:Inpadoc/Fam.& Legal Stat
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13408266

Basic Patent (No,Kind,Date): JP 8306582 A2 961122 <No. of Patents: 001>

PATENT FAMILY:

JAPAN (JP)

Patent (No,Kind,Date): JP 8306582 A2 961122

MANUFACTURE OF MULTILAYER TUBULAR CAPACITOR (English)

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Priority (No,Kind,Date): JP 95127438 A 950428

Applic (No,Kind,Date): JP 95127438 A 950428

IPC: * H01G-004/12; C25D-015/02

CA Abstract No: ; 126(10)138746Z

Derwent WPI Acc No: ; C 97-238920

Language of Document: Japanese

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DIALOG(R)File 347:JAPIO

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05351082 **Image available**

MANUFACTURE OF MULTILAYER TUBULAR CAPACITOR

PUB. NO.: 08-306582 [JP 8306582 A]

PUBLISHED: November 22, 1996 (19961122)

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APPL. NO.: 07-127438 [JP 95127438]

FILED: April 28, 1995 (19950428)

INTL CLASS: [6] H01G-004/12; H01G-004/12; C25D-015/02

JAPIO CLASS: 42.1 (ELECTRONICS -- Electronic Components); 12.6 (METALS -- Surface Treatment)

JAPIO KEYWORD:R007 (ULTRASONIC WAVES); R044 (CHEMISTRY -- Photosensitive Resins)

ABSTRACT

PURPOSE: To provide a miniaturized device of large capacitance which is free from current leak and excellent in producibility by providing a sintered body of a dielectric material layer which is formed by an electrophoresis method by using dielectric material powder for particle in electrodeposition solution in at least a dielectric layer of a dielectric layer and a conductor layer.

CONSTITUTION: Two platinum rods are made a cathode and an anode, the platinum rods of electrode set are immersed in slurry of ceramic dielectric material powder, a voltage is applied between both electrodes and a first layer of a ceramic dielectric material layer 2 is formed. Thereafter, both electrodes are immersed in slurry of conductor material powder, a voltage is applied between both electrodes and a first layer of a conductor material layer 3 is formed. Similarly as above, ceramic dielectric material layers 2, 2..., and conductor material layers 3, 3... are formed one by one and a material lamination body is obtained. The material lamination body is baked, a platinum rod is drawn out and a ceramic element assembly chip of a tube 1 is obtained.